

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yeo, *et al.* Docket No.: TSM03-0847
Serial No.: 10/826,602 Art Unit: 1795
Filed: April 16, 2004 Examiner: Raymond, Brittany L.
For: Lithography Apparatus for Manufacture of Integrated Circuits

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed August 22, 2008. Please amend the above-referenced application as follows.